

PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
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University of Illionois	08/18/2005
RECEIVING PARTY DATA	
Name:	National Science Foundation
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PROPERTY NUMBERS Total: 1	
Property Type	Number
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Invention Title: Use of Surface Chemistry to Improve the Properties of ION-implanted pn Junctions in Semiconductors

Inventor(s): Michael Jung, Rudiyanto Gunawan, Richard Braatz, Edmund Seebauer

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Patent or Application Serial No.: 11/192,339

Grant/Contract Number(s): CTS0203237, CTS9806329

Foreign Applications filed/intended in (countries): _____

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this 18th day of August, 20 05.

By Stephen K. Rugg (Name of Grantee/Contractor Official) Stephen K. Rugg (Signature)

Title Vice President for Administration, Comptroller

For UNIVERSITY OF ILLINOIS URBANA-CHAMPAIGN (Grantee/Contractor Organization)

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